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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

*(Use as many sheets as necessary)*

**Complete if Known**

Application Number	Not Known Yet 10/840 093
Filing Date	05/06/2004
First Named Inventor	Chao-Lung Chen
Art Unit	Not Known Yet 2813
Examiner Name	Not Known Yet
Attorney Docket Number	N1085-00288

Sheet	1	of	2
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## U. S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

**Examiner  
Signature**

/Thanh Nguyen/ (04/28/2006)

Date  
Considered

04/28/2006

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>2</sup> Applicant's unique citation designation number (optional). <sup>3</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>4</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>5</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>6</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>7</sup> Applicant is to place a check mark here if English language translation is attached.

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Sheet

2

of

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**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
TN	H	SATO ET AL., "Newly Developed Electro-Chemical Polishing Process of Copper as Replacement of CMP Suitable for Damascene Copper Inlaid in Fragile Low-k	
		Dielectrics", Electron Devices Meeting, 2001. IEDM Technical Digest. International, 2-5 Dec. 2001, Pages 4.4.1 - 4.4.4	
TN	I	GRANDIKOTA ET AL., "Influence of Plating Parameters on Reliability of Copper Metallization", Interconnect Technology Conference, 2002. Proceedings of the IEEE	
		2002 International, 3-5 June 2002, Pages 197 - 199	

Examiner Signature	/Thanh Nguyen/ (04/28/2006)	Date Considered	04/28/2006
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